



U.S.S.N. 10,656,986

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Lu et al.

Group Art Unit: 2813

Serial No.: 10,656,986

Examiner: Doty, H.A.

Filed: 09/04/2003

In Response to Office Action  
Dated: 11/09/2005

For: MULTIPLE EXPOSURE METHOD FOR FORMING  
PATTERNED PHOTORESIST LAYER

Attorney Docket No.: 67,200-1145

CERTIFICATE OF MAILING OR FACSIMILE TRANSMISSION

I hereby certified that this correspondence is (1) ☒ being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the Commissioner for Patents, P O Box 1450, Alexandria, VA 22313-1450 on March 9, 2006; or (2) ☐ being facsimile transmitted to the United States Patent and Trademark Office at facsimile number (571)-273-8300 on March \_\_\_\_, 2006.

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Signature

3/9/06

Date



U.S.S.N. 10,656,986

**RESPONSE TO OFFICE ACTION**

Assistant Commissioner  
for Patents  
P.O. Box 1450  
Alexandria, Va 22313-1450

Dear Sir:

In response to an Office Action mailed 11/09/2005,  
please enter the following amendments and consider the following  
remarks.